

ANSI/OESC TAG to ISO/TC 172/SC 3 Annual Report for 2010

Prepared by TAG/SC 3 Leader: Gordon Boulton

Number of Meetings Held during 2010: 0

Date: N/A

Location: N/A

Number of Meetings Scheduled for 2010: 1

Location: Tokyo, Japan, October

List any significant accomplishments for ANSI/OEOSC TAG/SC 3 this year.

Provided US comments on WG 2 project to ISO CD 9211-4 for *Optical coatings — specific test methods*. This is a revision to the document and incorporates a draft amendment. The US chairs this project.

The US (JDSU) supplied samples for a comparison test of the cheesecloth abrasion tester pad preparation methodology.

List any problems encountered by the ANSI/OEOSC TAG/SC 3 during the year

As of the date of this report, none of the IR materials suppliers who have expressed an interest in participating in WG 3 have joined OEOSC.